

2018 - 1

Silicon nitride multi nanolayer system fabricated in one reactor

Avotina Liga¹, Dekhtyar Yuri², Romanova Marina², Shulzinger Evgeny², Schmidt Ben³, Vilken Aleksandr², Zaslavski Aleksandr⁴, Enichek Gennady⁴

¹ University of Latvia,

² Riga Technical University ,

³ Physical Electronics, Chanhassen, Minnesota,

⁴ Joint Stock Company ALFA

Telecommunications, Electronics and Informatics

Nr. 4(8) / 2006 / ISSN 1857-0011

Disponibil online 28 May, 2018. Descarcări-1. Vizualizări-590



Copyright © 2011-2024 Instrumentul Bibliometric Național.
Institutul de Dezvoltare a Societății Informaționale.
Actualizat: 26.06.2024, accesat: 26.06.2024
Disponibil: <https://ibn.idsi.md>

